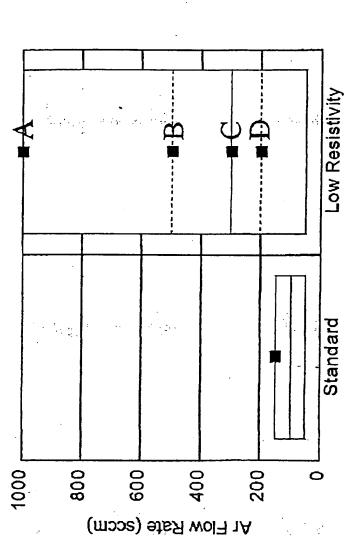


Range of Ar Flow Rates for Stable Plasma Operation



A: P/N 716-461378-JH2 S/N 16625-6 829 hole B: P/N 839-011907-121 S/N 1047-9 3249 hol C: P/N 839-011907-121 S/N 1047-15 3249 hol D: P/N 839-011907-121 S/N 1047-21 3249 hol

829 hole low resistivity electrode 3249 hole low resistivity electrode 3249 hole low resistivity electrode 3249 hole low resistivity electrode

